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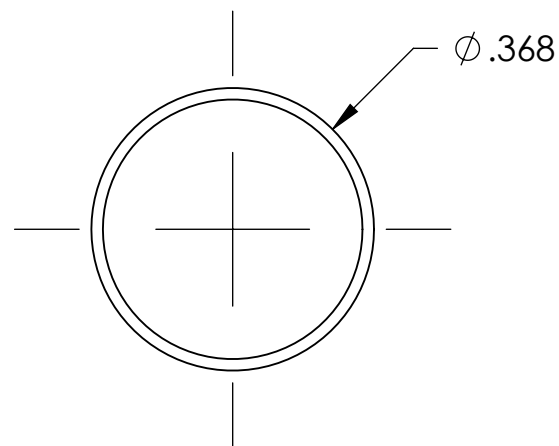
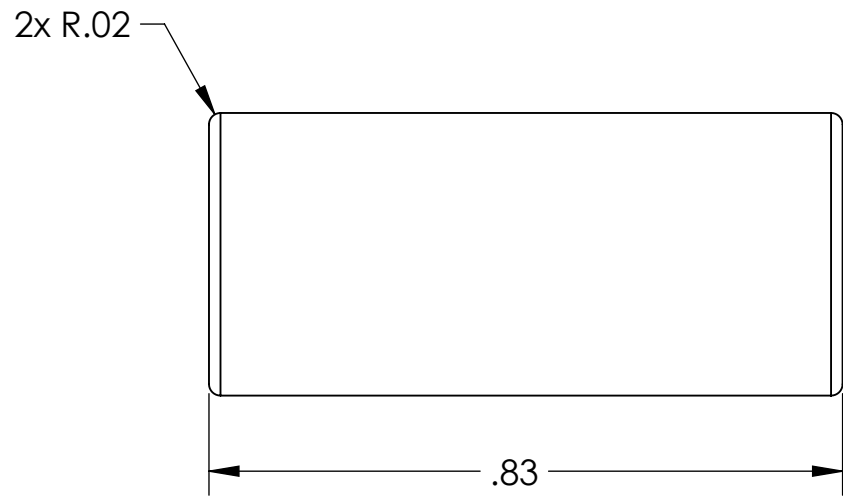
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NOTES CONTINUED:

5. SCRIBE, ENGRAVE, OR MECHANICALLY STAMP (NO INKS OR DYES) DRAWING PART NUMBER, REVISION (AND VARIANT OR "TYPE" IF APPLICABLE) ON NOTED SURFACE OF PART FOLLOWED ON THE NEXT LINE WITH A THREE DIGIT SERIAL NUMBER. SERIAL NUMBERS START AT 001 FOR THE FIRST ARTICLE AND PROCEED CONSECUTIVELY. USE MINIMUM 0.12" HIGH CHARACTERS, UNLESS THE SIZE OF THE PART DICTATES SMALLER CHARACTERS. A VIBRATORY TOOL MAY BE USED.  
 EXAMPLE: DXXXXXX-VY, TYPE-XX, S/N XXX  
 BAG AND TAG

- 6. APPROXIMATE WEIGHT = 0.025 LB.
- 7. MACHINE ALL SURFACES TO REMOVE OXIDES AND MILL FINISH. USE OF ABRASIVE REMOVAL TECHNIQUES IS NOT ALLOWED.
- 8. ALL PARTS SHALL BE MANUFACTURED IN ACCORDANCE WITH LIGO SPECIFICATION E0900364.

REV.	DATE	DCN #	DRAWING TREE #
v1	04 DEC 2012	E1201080-x0	-
-	-	-	-
-	-	-	-



D1201525 PIN, Z, OMC TRANSPORT FIXTURE, PART PDM REV: X-002, DRAWING PDM REV: X-001

D

C

B

A

D

C

B

A

NOTES AND TOLERANCES: (UNLESS OTHERWISE SPECIFIED)

DIMENSIONS ARE INCHES	
TOLERANCES: .XX ± .01 .XXX ± .005 ANGULAR ±1°	
1. INTERPRET DRAWING PER ASME Y14.5-1994. 2. REMOVE ALL SHARP EDGES .005-.015 3. DO NOT SCALE FROM DRAWING. 4. ALL MACHINING FLUIDS MUST BE FULLY SYNTHETIC, FULLY WATER SOLUBLE AND FREE OF SULFUR, SILICONE, AND CHLORINE.	
MATERIAL	FINISH
NITRONIC 60	63 μinch

**LIGO** CALIFORNIA INSTITUTE OF TECHNOLOGY  
 MASSACHUSETTS INSTITUTE OF TECHNOLOGY

SYSTEM: **ADVANCED LIGO** SUB-SYSTEM: **ISC**

NEXT ASSY: **D1201515**

PART NAME				PIN, Z, OMC TRANSPORT FIXTURE	
DESIGNER	J.LEWIS	03 DEC 2012	SIZE	DWG. NO.	REV.
DRAFTER	J.LEWIS	04 DEC 2012	<b>B</b>	<b>D1201525</b>	v1
CHECKER			SCALE: 2:1	PROJECTION:	SHEET 1 OF 1
APPROVAL					

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